

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Hiroki et al.)
)
Serial No.: 09/776,472)
)
Filed: February 2, 2001)
)
For: Thin Film Formation Apparatus And)
Method Of Manufacturing Self-Light-)
Emitting Device Using Thin Film)
Formation Apparatus)
)
Art Unit: 1762)
)
Confirmation No.: 7144)
)
Examiner: James Lin)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT (J)

Sir:

In response to the Final Rejection of August 8, 2006, a RCE being filed herewith, please
amend the above-identified application as follows: